

[DOCUMENT NAME] WRITTEN ABSTRACT

[ABSTRACT]

[PROBLEM TO BE SOLVED]

In a surface processing apparatus for spraying a processing gas onto the surface of an object to be processed through a hole-row such as a slit, the surface of the object having a large area can effectively be processed even if the hole-row is short.

[MEANS FOR SOLVING]

A plurality of electrode plates 11, 12 are arranged, in side-by-side relation, on a processor 1 of a plasma surface processing apparatus M. A slit-like hole-row 10a is formed between the adjacent electrode plates, and a hole-row group 100 is constituted by the side-by-side arranged hole-rows 10a. The object W is moved along the extending direction of each slit 10a by a moving mechanism 4.

[SELECTED FIGURE] FIG. 1